

# WK-9000 (White Knight<sup>™</sup>) Gas Purifiers

#### **Overview**

NANOCHEM<sup>®</sup> WK-9000 (White Knight<sup>™</sup>) purifiers offer the highest lifetimes and the best impurity removal efficiencies in a very economical design. The WK-9000 purifiers are available in both single and dual configurations. The optional dual purifier bypass includes a purge manifold.

## **Features and Benefits**

- For point-of-use to bulk flow specialty gas purification
- Highest Lifetimes
- Best Impurity Removal Efficiencies
  - Removes critical contaminants to sub part-per-trillion levels
- Enhances manufacturing process economy and improves equipment performance
- Provides consistently high purity gas under fluctuating inlet impurity conditions
- Improves component lifetime and reduces particle generation by removing moisture from corrosive gases
- Easy to install and operate
- No heating or cooling required
- Quick start up
- Metal parts are type 316L stainless steel, or Nickel 200
- Particle filters are PTFE
- Economical, low cost of ownership





## **Impurities Removed**

Gas Type	Contaminants	Outlet Purity	
Inerts - Nitrogen (N2),	H <sub>2</sub> O	< 86 ppt	
Argon (Ar), other inerts	O <sub>2</sub>	< 50 ppt	
	CO	< 100 ppt	
	CO <sub>2</sub>	< 24 ppt	
	Benzene	< 156 ppq	
	Toluene	< 93 ppq	
	Ethylbenzene	< 96 ppq	
	m,p-Xylene	< 79 ppq	
	o-Xylene	< 112 ppq	
	Refractories*	< 134 ppq	
	H <sub>2</sub>	< 1 ppb	
Ammonia (NH <sub>3</sub> )	$H_2O$	< 45 ppb	
	O <sub>2</sub>	< 0.1 ppb	
	CO <sub>2</sub>	< 11 ppb	
	Carbamate	< 11 ppb	
	GeH₄	< 1 ppb	
	SiH <sub>4</sub>	< 3 ppb	
	Siloxanes	< 40 ppb	
	Metals		
	Al	< 0.6 ppb	
	Cu	< 0.27 ppb	
	Fe	< 0.8 ppb	
	К	< 0.35 ppb	
	Na	< 0.27 ppb	
	Si	< 1.3 ppb	
	W	< 0.11 ppb	
	Zn	< 0.27 ppb	
	Zr	< 0.11 ppb	
-	Hydrocarbons from Liquid $NH_3$		
	Napthenic and Paraffins	85% removal	
	Ethyl Benzene	96% removal	
	Dissolved other HC	<200 ppb	
	Hydrocarbons from Gaseous $NH_3$		
	n-Butane	< 30 ppb	
	Ethylbenzene	< 30 ppb	
Carbon Dioxide (Purifier	Isopropyl Alcohol	< 200 ppt	
material HCX)	Acetone	< 93 ppt	
	Propene	< 1 ppt	
	Ethanol	< 1 ppt	
	Carbon Disulfide	< 1 ppt	
	Hexane	< 1 ppt	
	Benzene	< 1 ppt	

Gas Type	Contaminants	<b>Outlet Purity</b>	
Carbon Dioxide (Purifier material HCX) continued	Heptane	< 1 ppt	
	Toluene	< 1 ppt	
	m,p-Xylene	< 1 ppt	
	o-Xylene	< 1 ppt	
	Ethyl Toluene	< 1 ppt	
	1,3,5-Trimethyl Benzene	< 1 ppt	
	1,2,4-Trimethyl Benzene	< 1 ppt	
	DichloroBenzene	< 1 ppt	
Silane (SiH <sub>4</sub> )	$H_2O$	< 100 ppt	
	O <sub>2</sub>	< 100 ppt	
	CO <sub>2</sub>	< 100 ppt	
	CO**	<1ppb	
	Chlorosilanes, disilane, siloxanes, arsine, phosphine		
Hydrogen (H <sub>2</sub> )	H <sub>2</sub> O	< 100 ppt	
	O <sub>2</sub>	< 100 ppt	
	CO <sub>2</sub>	< 100 ppt	
Methane (CH <sub>4</sub> )	CO**	<1 ppb	
Ethane ( $C_2H_6$ ), other HC	NOx, SOx, H2S		
Sulfur Hexafluoride (SF $_6$ )	H₂O in inert gas	< 100 ppt	
	$O_2$ in inert gas	< 100 ppt	
	CO₂ in inert gas	< 100 ppt	
Carbon Tetrafluoride	H <sub>2</sub> O in sulfur hexafluoride	< 10 ppb	
(CF <sub>4</sub> )	O <sub>2</sub> in sulfur hexafluoride	< 10 ppb	
Other Fluorocarbons	H <sub>2</sub> O in sulfur hexafluoride	< 10 ppb	
	O2 in sulfur hexafluoride	< 10 ppb	
Oxygen (O <sub>2</sub> ),	H <sub>2</sub> O	< 10 ppb	
Carbon Dioxide (CO <sub>2</sub> ),	H <sub>2</sub> O	< 10 ppb	
Nitrous Oxide (N <sub>2</sub> O)	H <sub>2</sub> O	< 10 ppb	
Carbon Monoxide (CO)	Metal Carbonyls: Fe, Ni		
Corrosives (HCI, HBr, CI <sub>2</sub> ,	H₂O in inert gas	<1 ppb	
SiH <sub>2</sub> Cl <sub>2</sub> , SiHCl <sub>3</sub> , BCl <sub>3</sub> )	H₂O in HBr	< 100 ppb	
	H₂O in HCl	< 100 ppb	
	Volatile Metals***		
	Мо	< 4 ppb	
	Ti	< 13 ppb	
	Fe(CO)5	< 50 ppb	

Impurity removal depends on purifier material and incoming gas specification

\*Refractories as TMDSO (Tetramethyldisiloxane) \*\*CO is removed efficiently by OMX & OMX-Plus™ media at low flow rates (recommend 1/10 of normal flow rate)

\*\*\*Metals removed as measured on wafer via VPD-ICPMS:

Al, Ca, Cr, Fe, Mg, Ni, K, Na, Zn

Metals removal as demonstrated by intrinsic resistivity measurements on wafer grown by TCS: Without MTX Purifier: <200 ohm-cm

With MTX Purifier: > 2500 ohm-cm and total metals on water <1E10 atoms/cm2

### Analytical Characterization of NANOCHEM<sup>®</sup> NHX<sup>™</sup> Purifier

Impurity/Matrix	Capacity (L/L)	Efficiency (ppb)	Challenge (ppm)	Method
H₂S in He	6	<0.3 (D/L)	50	GC-AED
H₂S in Ar	31	<0.3 (D/L)	35	API-MS
$H_2S$ in $NH_3$	25	<45 (D/L)	1000	FTIR
CO <sub>2</sub> in He	5	<11 (D/L)	500	GC-DID
CO <sub>2</sub> in NH <sub>3</sub>	_	<11 (D/L)	25	GC-DID
$GeH_4$ in $N_2$	_	<0.1 (D/L)	2.5	API-MS
$SiH_4$ in $N_2$	_	<0.1 (D/L)	2.5	API-MS
Siloxanes in N <sub>2</sub>	_	<-0.1 (D/L)	(trace)	API-MS
$GeH_4$ in $NH_3$	_	<0.5 (D/L)	1.0	GC-AED
$SiH_4$ in $NH_3$	_	<1 (D/L)	1.0	GC-AED
TEOS (siloxane) in NH <sub>3</sub>	_	<40 (D/L)	640	GC-DID
O <sub>2</sub> in NH <sub>3</sub>	—	<50 (D/L)	100	GC-DID

### **Purifier Models**

	WK-9000H Single Purifier	WK-9000 Dual Purifier
Media bed volume	9000 ml	9000 ml
Maximum flow rate (in nitrogen), slpm (NM³/hr)	2000 (120)	4000 (240)*
Pressure Drop at maximum flow rate (psi), tested in N2 at 90 psi inlet	<17 (<0.12 MPa)	<17 (<0.12 MPa)
Max permissible operating pressure, psi	250 (1.7 MPa)	250 (1.7 MPa)

\*Both purifiers must be used in parallel path configuration

### **Specifications**

- 0.003 μm filter with 99.9999999% retention (PTFE or 316L SS)
- Internal surface finish < 15  $\mu$ in Ra
- Maximum operating temperature is 40°C
- Inlet and outlet isolation valves

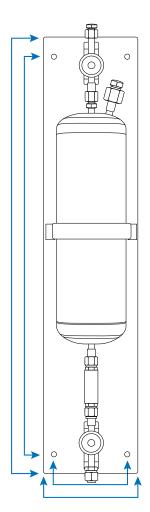
#### Connections

• Male inlet and outlet connections, 1/2" face seal

#### **Options**

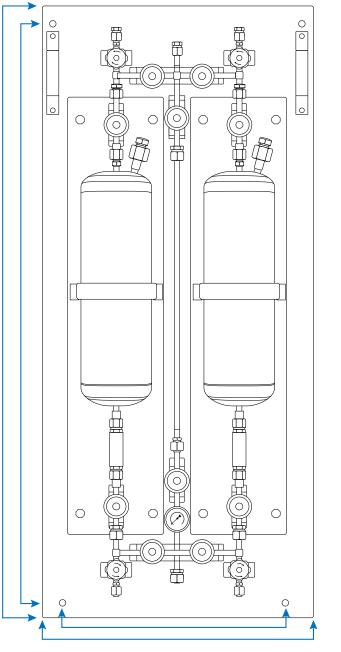
Three-valve manifold with isolation and bypass valves allows disconnection of purifier without interrupting process gas flow

#### **Dimensions**



Mounting Holes: Width 6.68" (169.7 mm) +/- 0.010" (0.254 mm) Back Plate: Width 8.75" (222.3 mm) +/- 0.010" (0.254 mm) Mounting Holes: Length 36.00" (914.4 mm) +/- 0.010" (0.254 mm) Back Plate: Length 40.00" (1016.0 mm) +/- 0.010" (0.254 mm)

#### NANOCHEM® Single Purifier Model WK-9000H



Mounting Holes: Width 22.00" (558.8 mm) +/- 0.010" (0.254 mm) Back Plate: Width 25.00" (635.0 mm) +/- 0.010" (0.254 mm) Mounting Holes: Length 53.00" (1346.2 mm) +/- 0.010" (0.254 mm) Back Plate: Length 56.00" (1422.4 mm) +/- 0.010" (0.254 mm)

Dimensions in inches (mm)

#### NANOCHEM® Dual Purifier Model WK-9000 with Bypass Model BP-WK-9000

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